

LAMP2015 Session Chart (as of May 20)

	DAY-1: May 26 (Tue)	DAY-2: May 27 (Wed)	DAY-3: May 28 (Thu)	DAY-4: May 29 (Fri)													
8:30					8:30												
9:00		ROOM 1 Session 9 LPM SP L1-1: Hybrid Femto-second Laser Manufacturing -3D glass micro-structuring- (8:40-10:10)	ROOM 2 Session 12 LPM Pulsed Laser Deposition (8:50-10:10)	ROOM 3 Session 15 LPM Advanced Laser Applications (8:40-10:10)	ROOM 4 Session 18 HPL 3 Welding 1 (Hybrid Welding of Thick Plates) (8:30-10:10)	9:00											
9:30			ROOM 1 Session 21 LPM Nanoparticles (8:50-10:10)	ROOM 2 Session 25 LPM Ultrafast Laser Micromachining of Glass (9:10-10:10)	ROOM 3 Session 29 LPM Surface Processing (8:50-10:10)	ROOM 4 Session 33 HPL 6 Welding 3 (Plastic) (8:30-10:10)	9:30										
10:00						ROOM 1 Session 37 LPM Industrial Applications (8:50-10:10)	ROOM 2 Session 40 LPM Solar Cells (8:50-10:10)	ROOM 3 Session 43 No Session セッションなし	ROOM 4 Session 46 HPL 10 Welding 4 (8:50-10:10)	10:00							
10:30		COFFEE BREAK (Event Hall)		COFFEE BREAK (Event Hall)		COFFEE BREAK (Event Hall)				10:30							
11:00	MAIN HALL Opening Remark (10:30-10:40) Plenary Session (10:40-12:40)	ROOM 1 Short Presentations for Poster Session I and II (10:30-12:10)		ROOM 1 Session 22 LPM SP L3-1 Laser Synthesis and Excitation of Nanoparticles (10:40-12:10)	ROOM 2 Session 26 LPM Glass Drilling (10:40-12:10)	ROOM 3 Session 30 LPM Micro-Machining (10:40-12:00)	ROOM 4 Session 34 HPL 7 Cutting and Drilling (10:50-12:10)	ROOM 1 Session 38 LPM Sensor Fabrication (10:30-12:10)	ROOM 2 Session 41 LPM Laser Printing and Devices (10:30-12:10)	ROOM 3 Session 44 LPM Micro-processing with fs Laser (10:30-12:10)	ROOM 4 Session 47 HPL 11 Surface Treatment (Cladding) (10:30-12:10)	11:00					
11:30		EVENT HALL Poster Session I & Exhibition (LUNCH TIME) (12:10-14:00)		EVENT HALL Poster Session II & Exhibition (LUNCH TIME) (12:10-14:00)		LUNCH TIME				11:30							
12:00		LUNCH TIME								12:00							
12:30		EVENT HALL Poster Session I & Exhibition (LUNCH TIME) (12:10-14:00)		EVENT HALL Poster Session II & Exhibition (LUNCH TIME) (12:10-14:00)		LUNCH TIME				12:30							
13:00		EVENT HALL Poster Session I & Exhibition (LUNCH TIME) (12:10-14:00)		EVENT HALL Poster Session II & Exhibition (LUNCH TIME) (12:10-14:00)		LUNCH TIME				13:00							
13:30		EVENT HALL Poster Session I & Exhibition (LUNCH TIME) (12:10-14:00)		EVENT HALL Poster Session II & Exhibition (LUNCH TIME) (12:10-14:00)		LUNCH TIME				13:30							
14:00	ROOM 1 Session 1 LPM SP L2-1 Near-field Nanopatterning (14:00-15:40)	ROOM 2 Session 3 LPM Periodic Surface Structures and Applications (14:00-15:20)	ROOM 3 Session 5 LPM Micro-Welding (14:00-15:40)	ROOM 4 Session 7 HPL 1 Oscillator and Apparatus (14:00-15:50)	ROOM 1 Session 10 LPM SP L1-2: Hybrid Femto-second Laser Manufacturing -Two-photon polymerization- (14:00-15:30)	ROOM 2 Session 13 LPM Micro/Nano Patterning (14:00-15:40)	ROOM 3 Session 16 LPM Peening and Annealing (14:00-15:20)	ROOM 4 Session 19 HPL 4 Welding 2 (14:00-15:50)	ROOM 1 Session 23 LPM SP L3-2 Laser Synthesis and Excitation of Nanoparticles (14:00-15:30)	ROOM 2 Session 27 LPM Nano Ripple Formation (14:00-15:30)	ROOM 3 Session 31 LPM Internal Processing by Ultrafast Laser (14:00-15:30)	ROOM 4 Session 35 HPL 8 Additive Manufacturing 1 (14:00-15:10)	ROOM 1 Session 39 LPM Laser-Based Direct Write Technologies (13:10-14:50)	ROOM 2 Session 42 LPM Advanced Laser Materials Processing (13:30-14:40)	ROOM 3 Session 45 LPM Laser-Induced Modification and Patterning for 2D and 3D Devices (13:30-14:50)	ROOM 4 Session 48 HPL 8 Additive Manufacturing 2 (13:30-14:40)	14:00
14:30																	14:30
15:00													COFFEE BREAK (Event Hall)				15:00
15:30													MAIN HALL Session 49 LPM/HPL Joint Session (15:10-16:10)				15:30
16:00	ROOM 1 Session 2 LPM SP L2-2 Near-field Nanopatterning (16:00-17:30)	ROOM 2 Session 4 LPM LPSS (16:00-17:40)	ROOM 3 Session 6 LPM Fundamental Aspects (16:00-18:00)	ROOM 4 Session 8 HPL 2 Simulation (16:10-17:40)	ROOM 1 Session 11 LPM SP L1-3: Hybrid Femto-second Laser Manufacturing -Hybrid technology- (16:00-17:30)	ROOM 2 Session 14 LPM Drilling and Cutting (16:00-17:40)	ROOM 3 Session 17 LPM Biomedical Applications (16:00-17:10)	ROOM 4 Session 20 HPL 5 Monitoring (16:10-17:50)	ROOM 1 Session 24 LPM SP L3-3 Laser Synthesis and Excitation of Nanoparticles (16:00-17:30)	ROOM 2 Session 28 LPM Electronics Applications (16:00-17:40)	ROOM 3 Session 32 LPM Surface Formation and Deposition (16:00-17:40)	ROOM 4 Session 36 HPL 9 Surface Treatment (16:00-17:40)	Outstanding Awards (16:10-) Closing Remark (-16:30)				16:00
16:30																	16:30
17:00																	17:00
17:30																	17:30
18:00									BREAK								18:00
18:30													To Banquet (on foot from the venue, 18:30-)				18:30
19:00													BANQUET (19:00-21:00) Rihga Royal Hotel Kokura, 4F "Royal Hall"				19:00
21:00																	21:00